Microcoat[™] MS450 Sputtering 2 Cathodes (1 inch and 6 inches) Pure Ar, single gas, gas mixture and reactive atmosphere DC (150 W on 1 inch and 1500 W on 6 inches), RF (300 W) powering units Co – deposition





Kenosistec [™] Sputtering 3 Cathodes (3 inches) Pure Ar, single gas, gas mixture and reactive atmosphere DC (500 W), RF (300 W) powering units Substrate plasma etching Substrate heating up to 450 °C and cooling during deposition Confocal co – deposition PLC controlled processes

THIN FILMS FOR BIOMEDICAL APPLICATIONS

THIN FILMS for JOINING



Development of antibacterial and antiseptic layers for: biomedical, ICT, food processing, fabrics, space missions and other applications.

	bulk W
	steel
	He or H ₂ O coolant

Development of thin films for joining Fe to W, for thermonuclear fusion energy production (ITER)

P	
	I T A
- 1888 S	-98-98-882



THIN FILMS FOR ENERGY PRODUCTION



Development of an innovative Intermediate Temperature Solid Oxide Fuel Cell (T-SOFC)

THIN FILMS FOR SENSORS







Development of Surface Plasmon Resonance (SPR) sensors and magneto optical sensors on waveguide and fibers.



PROTECTIVE AND DECORATIVE COATINGS



Development of decorative and protective coatings for metals (iron, copper, stainless steel, etc.), polymers, fabrics. Metal-like sputtered layers on polymeric components.

THIN FILMS FOR SPECIAL JOINING PROCESSES



Development of interlayer for ceramics, glasses and metals joining.

THIN FILMS FOR ENERGY STORAGE





Development of innovative layer for Li - based batteries. EU project "ALISE".





WE ARE OPEN FOR COLLABORATIONS! (Just Ask!)